

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q61572

Noriaki ODA

Appln. No.: 09/739,620

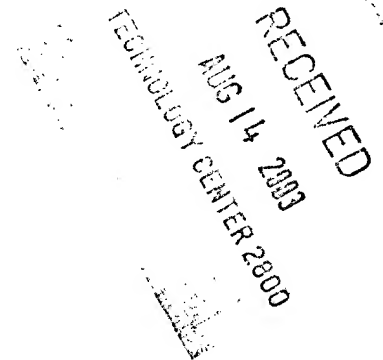
Confirmation No.: 4739

Group Art Unit: 2812

Filed: December 20, 2000

Examiner: Ha Nguyen

For: SEMICONDUCTOR DEVICE WITH COPPER-BASED WIRING LINES AND  
METHOD OF FABRICATING THE SAME



**AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 9, 2003, please amend the above-identified application as follows on the accompanying pages.

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